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U.S. UTILITY Patent Application

APPL NUM 10016633	FILING DATE 10/30/2001	CLASS 216	SUBCLASS 757	GAU 1748	EXAMINER Tren, B
**APPLICANTS: Peiter Martin, Marx Eckhard, Mautz Karl. 785					
**CONTINUING DATA VERIFIED					
** FOREIGN APPLICATIONS VERIFIED:					
PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>			
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no Verified and Acknowledged Examiner's initials				ATTORNEY DOCKET NO SC0142WD	
TITLE : Wafer scribing method and wafer scribing device					

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED		
			Total Claims		Print Claim for O.G
ISSUE FEE		Primary Examiner	DRAWING		
Amount Due	Date Paid		Sheets Drawg.	Figs.Drawg.	Print Fig.
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	Application Examiner		
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